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Firm Name	VOLPE AND KOENIG, P.C.			
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Printed name	Ryen W. O'Donnell			
Date	March 22,2007	Reg. No.	53,401	

SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT

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UNITED STATES PATENT AND TRADEMARK OFFICE

In the PATENT APPLICATION of:

Mervyn J. Miles et al.

Application No.:

10/612,133

Confirmation No.: 3323

Filed:

July 2, 2003

For: RESONANT SCANNING PROBE

MICROSCOPE Group: 2

2878

Examiner:

Thanh X. Luu

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Further to Applicants' Duty of Disclosure pursuant to 37 C.F.R. §1.56, Applicants wish to bring to the Examiner's attention the material cited on the enclosed PTO-1449 form. Pursuant to 37 C.F.R. §1.98(a)(2)(ii), copies of the cited U.S. publications and/or patent documents have not been included.

It is respectfully requested that the Examiner consider these documents and return an initialed copy of the PTO-1449 form indicating his consideration of the cited materials.

Respectfully submitted,

Miles et al.

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Sheet _1_ of _1_ FORM PTO-1449 ATTY. DOCKET NO. SERIAL NO. SHP-PT077 10/612,133 U.S. DEPARTMENT OF COMMERCE **APPLICANT** PATENT AND TRADEMARK OFFICE Mervyn J. Miles et al. INFORMATION DISCLOSURE **FILING DATE GROUP** STATEMENT BY APPLICANT 07/02/2003 2878 (Use several sheets if necessary) **U.S. PATENT DOCUMENTS** FILING DATE IF APPROPRIATE FXAMINER DOCUMENT NUMBER DATE CLASS SUBCLASS AA 11/1972 3,702,398 Van-Essen et al. AB 05/1995 5,412,980 Elings et al. AC 5,566,159 10/1996 Shapira AD 6.094,971 08/2000 Edwards et al. 05/2001 ΑE 6,236,783 Mononobe et al. FOREIGN PATENT DOCUMENTS TRANSI ATION DOCUMENT NUMBER DATE COUNTRY CLASS SUBCLASS VES NO ΑI 0 8 9 9 6 4 8 9/1998 Europe 09/2003 AF 5 4 5 5 3 8 **A1** Europe 5 3 66 AG 1 9 1 4 10/1996 Germany 9 2 33 AΗ 1 8 5 8 5/2000 Germany ΑJ 2 0 0 4 5 19 1/2001 X* 1 Japan X* AK 2 0 0 0 19 97 36 7/2000 Japan OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) M. Antognozzi, et al., A New Method To Measure The Oscillation Of A Cylindrical Cantilever: "The Laser AL Reflection Detection System," 04/2000, Review of Scientific Instruments, Volume 71, No. 4, pp 1689-1694 S.K. Sekatskii, et al., Time-Gated Scanning Near-Field Optical Microscopy, 10/2/2000, Applied Physics AM Letters, Volume 77, No. 14, pp 2089-2091 S.H. Simpson, et al., Analysis Of The Effect Arising From The Near-Field Optical Microscopy Of AN Homogeneous Dielectric Slabs, 09/1/2001, Optics Communications 196, pp 17-31 Khaled Karrai, et al., Piezoelectric tip-sample control for near field optical microscopes, 04/3/1995, American AO Institute of Physics, Vol. 66, No. 14, pp 1842-1844 Claire E. Jordan, et al., Removing optical artifacts in near-field scanning optical microscopy by using a three-AP dimensional scanning mode, 09/1/1999, Journal of Applied Physics, Vol. 86, No. 5, pp 2785-2789 Oshikane et al., Scanning Near-Field Optical Microscope With A Small Spherical Protrusion Probe Excited AQ With WGM Resonances, Optical Memory & Neural Networks 2000, Vol. 9, No. 3, pp 147-168 Oshikane et al., 3D-FDTD and experimental analysis of a resonant microcavity probe for high-resolution AR SNOM, Physics Devices & Information Processing, 07/1999, Vol. 3791, pp 57-62 DATE CONSIDERED **EXAMINER**

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.